

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

Fumio FUTAMI, et al.

Serial No. 10/762,551

Group Art Unit: 2613

Confirmation No. 3204

Filed: January 23, 2004

Examiner: David S. Kim

For: METHOD OF AND APPARATUS FOR PROVIDING MULTI-WAVELENGTH LIGHT  
SOURCE

**AMENDMENT**

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

This is in response to the Office Action mailed May 4, 2009.

Reconsideration of the claims is respectfully requested. The following amendments and remarks are respectfully submitted.